

Tutorial

2

SAN JOSE STATE UNIVERSITY ELECTRICAL
ENGINEERING DEPARTMENT

Getting Started with TCAD, a Simple Bar of Silicon

PROCESS INTEGRATION AND IC DESIGN GROUP SAN JOSE STATE UNIVERSITY

A tutorial guide for using Synopsys TCAD tools

David W. Parent
Assistant Professor
Electrical Engineering, SJSU
One Washington Square
San Jose, CA 95192-0084
Phone 408.924.3963 • Fax 408.924.2925

Table of Contents

CHAPTER 1: STARTING THE SENTAURUS TCAD TUTORIALS.....	5
Opening the tools in a webbrowser	5
Doing the tutorials:	9
CHAPTER 2: SIMPLE EXAMPLE SHOWING HOW TO SIMULATE A BAR OF SILICON.....	10
Downloading the Example File:.....	10

LIST OF FIGURES:

Figure 1: Starting a Web Browser.....	6
Figure 2: Open a file in a Web Browser.....	6
Figure 3: Open a file (File system).....	7
Figure 4: Location of Sentaurus Training.....	7
Figure 5: Main Menu of Sentaurus Training.....	8
Figure 6: Bookmark this page.....	8
Figure 7: Making a directory.....	10
Figure 8: Navigating to the sentaurus directory.....	11
Figure 9: Saving as res_bar.gzp.....	11
Figure 10: Starting Sentaurus Workbench.....	12
Figure 11: Sentaurus Workbench.....	12
Figure 12: Click on Unpack.....	13
Figure 13: Click OK twice.....	13
Figure 14: The resistor bar project is loaded.....	13
Figure 15: Showing Sentaurus Structure Editor commands.....	15
Figure 16: Commands for Sentaurus Structure Editor.....	15
Figure 17: Showing Sentaurus Device commands.....	16
Figure 18: Commands for Sentaurus Device.....	16
Figure 19: Showing commands for Inspect.....	17
Figure 20: Inspect Commands.....	17
Figure 21: Unlocking the project.....	18
Figure 22: Running the project.....	19
Figure 23: Setting the Queue to use for the project.....	19
Figure 24: Results of one run of the project.....	20
Figure 25: User Preferences.....	20
Figure 26: Set all Tech_plot to tecplot_sv -mesa.....	21
Figure 27: Viewing with tecplot_sv -mesa.....	21
Figure 28: SDE results.....	22
Figure 29: Plotting Results from SDevice with Inspect.....	23
Figure 30: Setting X-Axis.....	24
Figure 31: Setting Y-Axis.....	24
Figure 32: Electrical Results for a Bar of Silicon.....	25
Figure 33: Changing MGSX to .1um.....	25
Figure 34: Change value of MGSX.....	26
Figure 35: MGSY to .1um.....	26
Figure 36: Change value of MGSY.....	27
Figure 37: Rerun the project.....	28
Figure 38: Saving Project.....	28
Figure 39: Results of finer grid.....	29
Figure 40: Viewing the SDevice run time.....	29
Figure 41: Sdevice starts.....	30
Figure 42: Run statistics for Sdevice.....	30
Figure 43: No change in results!.....	30
Figure 44: Editing a variable.....	31
Figure 45: Adding experimental values.....	31
Figure 46: Add 5 values at powers of 10 doping levels.....	32
Figure 47: Experiments almost all set up.....	32
Figure 48: Change MGSX and MGSY back to 10.....	32
Figure 49: Cleanup project.....	33
Figure 50: Clean up results.....	33
Figure 51: Project ready to run.....	34
Figure 52: Results.....	34
Figure 53: Opening Open Office Calc.....	34
Figure 54: Results of varying the doping levels of a Silicon Bar.....	35
Figure 55: Deleting a variable.....	35
Figure 56: Selecting which value to keep.....	36
Figure 57: Adding the parameter back.....	36
Figure 58: NA added back.....	36
Figure 59: Adding values to the H.....	37
Figure 60: Varying H in the SWB manager.....	37
Figure 61: Results of Varying H.....	38
Figure 62: R. Vs H.....	39
Figure 63: Physics statement.....	39
Figure 64: HighFieldSaturation Flag.....	39
Figure 65: Results with High Field Mobility.....	40
Figure 66: Preprocess Nodes.....	41
Figure 67: New Experiment H=1-10um, and MGSY=1um.....	41

Acknowledgements:

Chapter 1: Starting the Sentaurus TCAD Tutorials

Opening the tools in a webbrowser

Synopsys has on-line training that can be accessed from a web browser. There are a few typos here and there, but it should be easy to follow. The tutorials are quite lengthy so give yourself plenty of time to complete them. If you already know a TCAD tool and process engineering you probably can reduce your completion time from the estimated completion time in half.

1. First log (ssh or vnc) in remotely or at a Unix station and start a terminal
2. Start a web browser (Figure 1).
3. Go to File... Open File (Figure 2).
4. Click on Filesystem in the left control area of Figure 3.
5. Click on apps in the right control area of Figure 3.
6. Click on apps, synopsys, TCAD, tcad, current, Example_Library, Sentaurus_Training (Figure 4).
7. Double Click on main_menu.html (Figure 4).
8. The web browser should look like Figure 5. Bookmark the page by going to Bookmarks.. Book mark this page (Figure 6).

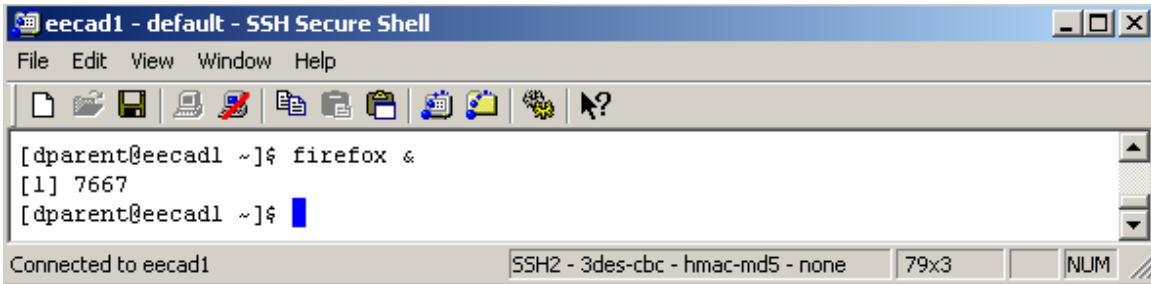


Figure 1. Starting a Web Browser.

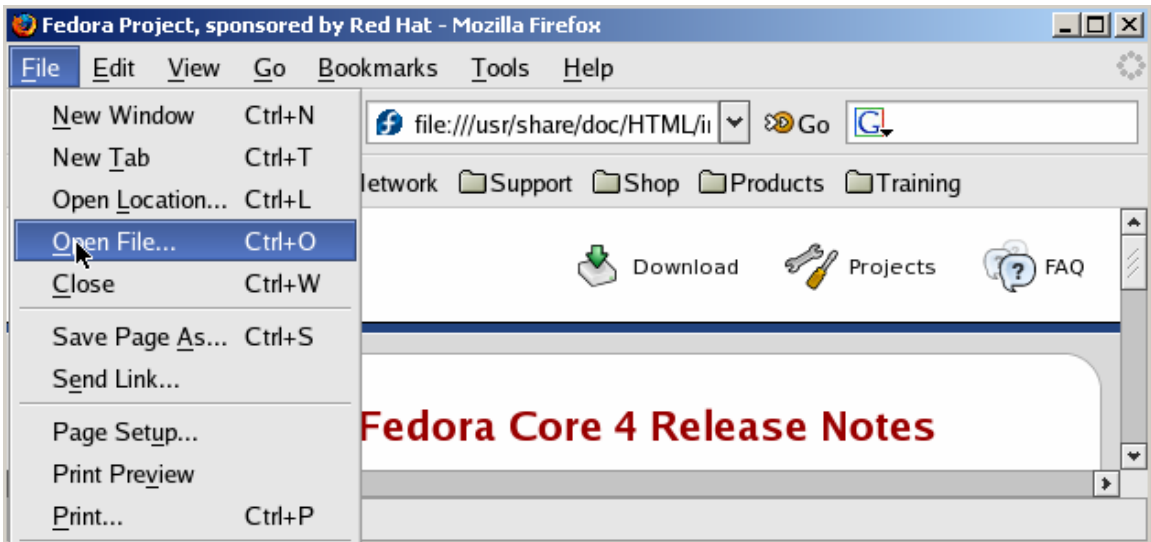


Figure 2. Open a file in a Web Browser.

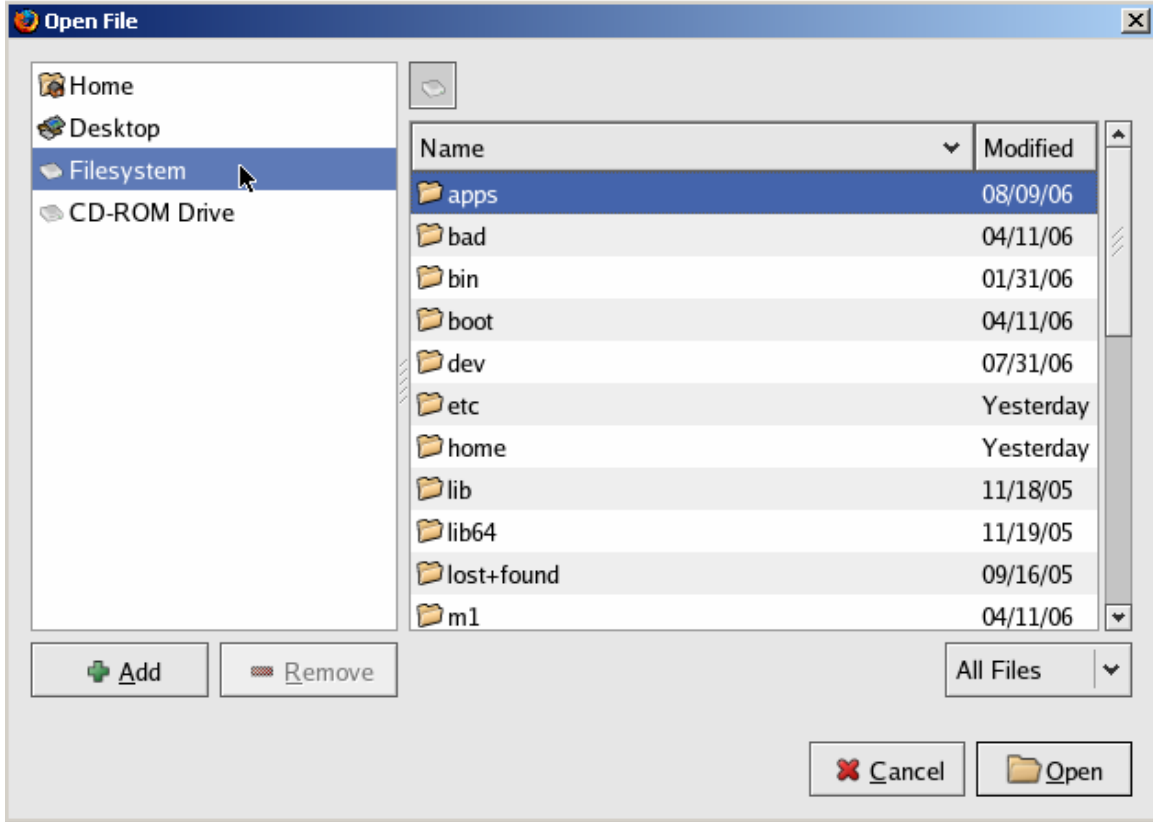


Figure 3: Open a file (File system).

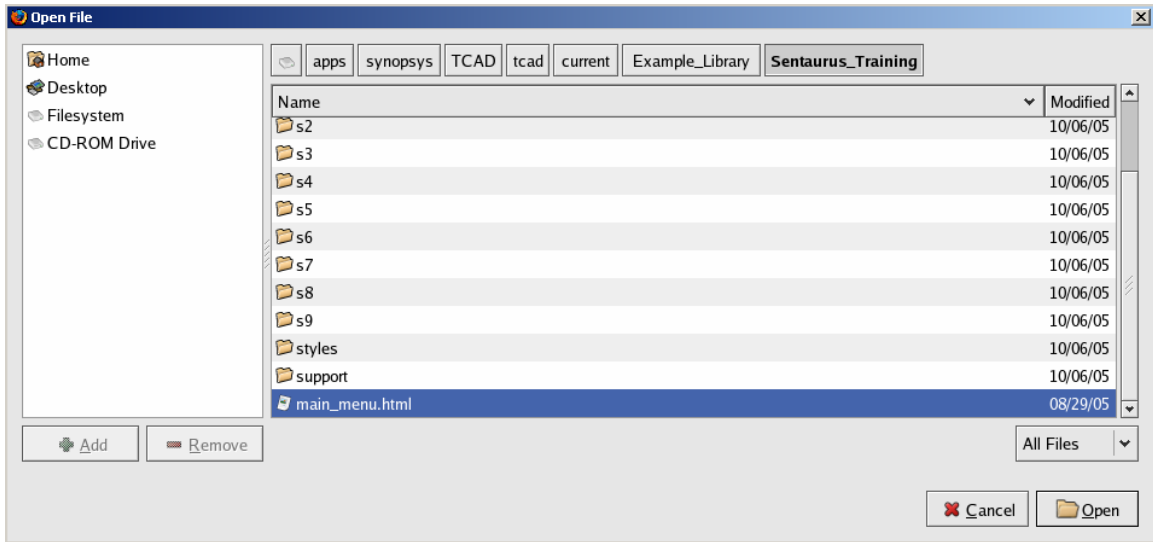


Figure 4: Location of Sentaurus Training.

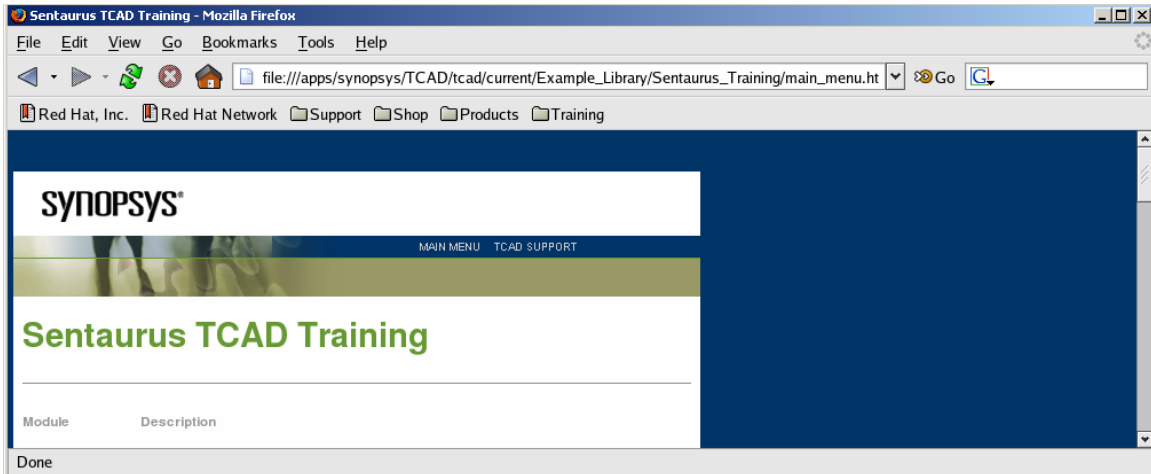


Figure 5: Main Menu of Sentaurus Training.

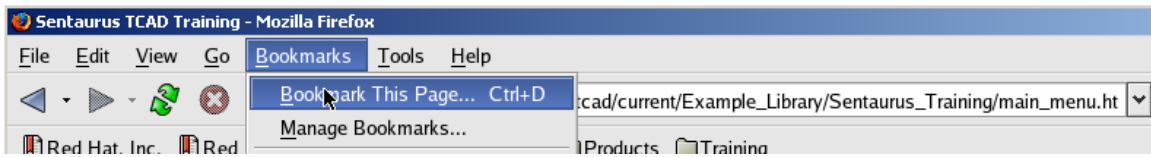


Figure 6: Bookmark this page.

Doing the tutorials:

In order to understand this tutorial, you should do the following tutorials provided by Synopsys

1. Tool Overview
2. Sentaurus Workbench

Chapter 2: Simple example showing how to simulate a bar of silicon

Downloading the Example File:

Make a directory in your home directory call Sentauros. (Figure 1Figure 7)

A terminal window titled "eecad38.engr.sjsu.edu:12 (dparent) Desktop" showing a sequence of commands: [dparent@eecad38 ~]\$ followed by a blank line, [dparent@eecad38 ~]\$ followed by a blank line, [dparent@eecad38 ~]\$ mkdir sentaurus, [dparent@eecad38 ~]\$ cd sentaurus, and [dparent@eecad38 ~/sentaurus]\$ followed by a cursor.

```
[dparent@eecad38 ~]$  
[dparent@eecad38 ~]$  
[dparent@eecad38 ~]$ mkdir sentaurus  
[dparent@eecad38 ~]$ cd sentaurus  
[dparent@eecad38 ~/sentaurus]$ █
```

Figure 7: Making a directory.

Using a web browser, download into your account the sample file:

www.engr.sjsu.edu/dparent/ee221/res_bar.gzp

Download the file into your sentaurus directory (Figure 8 and Figure 9)

Start Sentauros workbench by typing `smb e` at the command line (Figure 10).

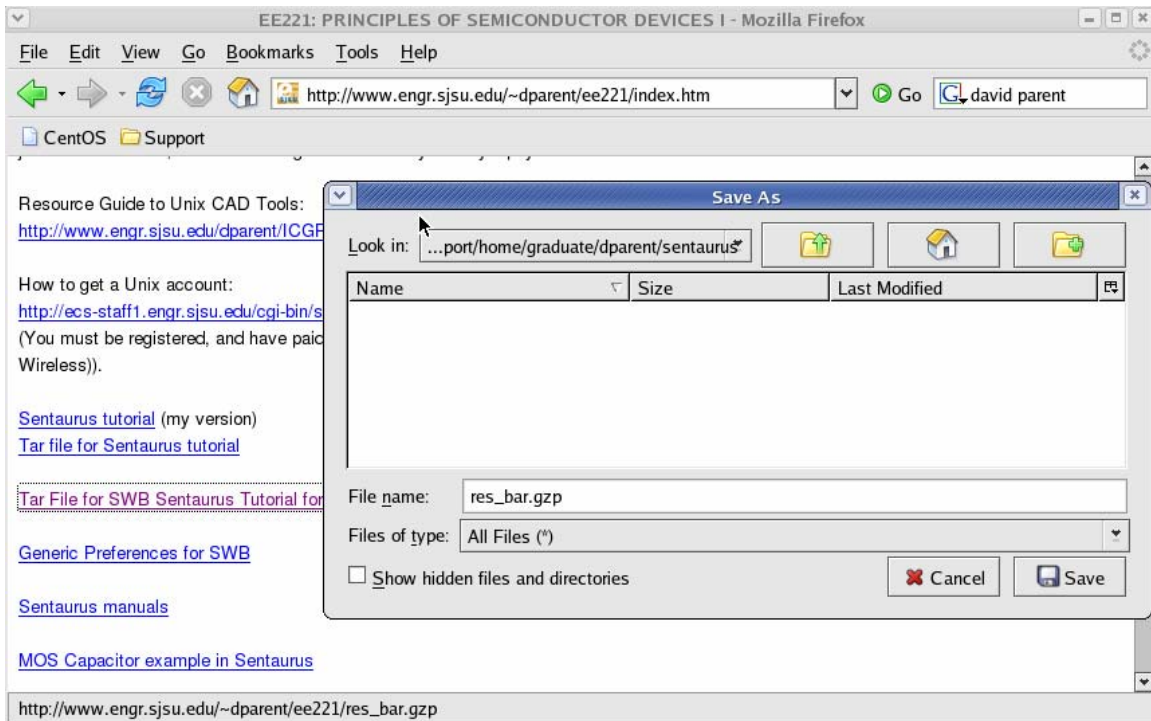


Figure 8: Navigating to the sentaurus directory.

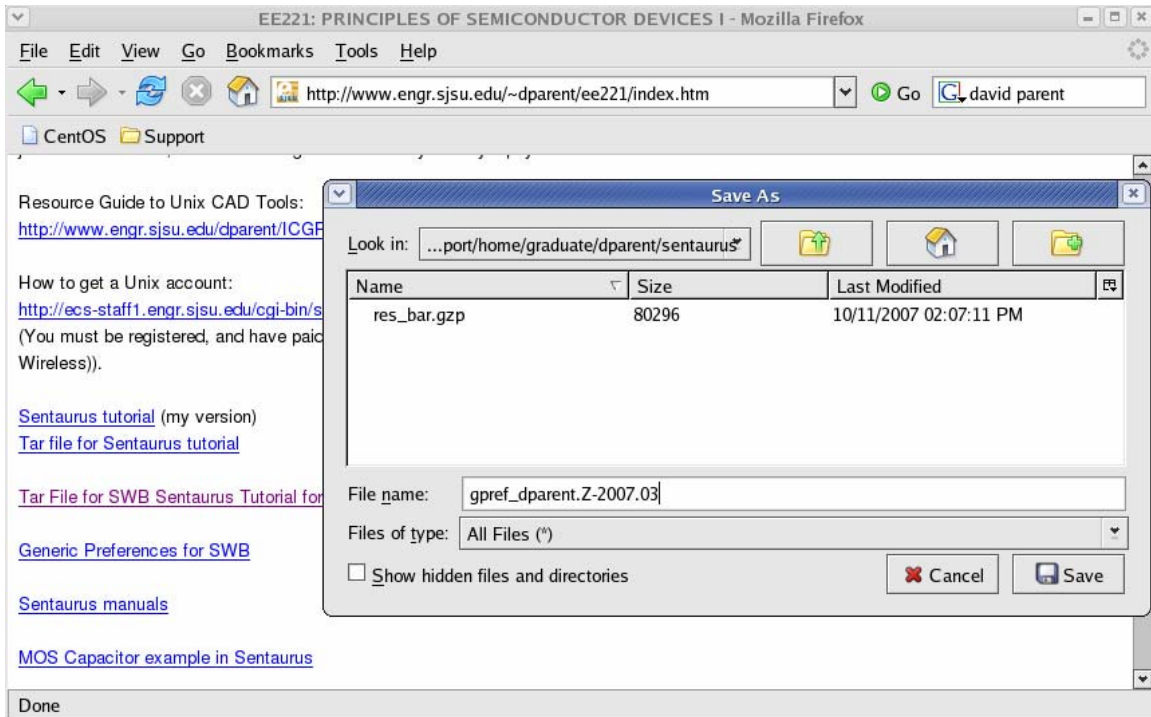


Figure 9: Saving as res_bar.gzp.



Figure 10: Starting Sentaurus Workbench.

After starting Sentaurus Workbench you should see the interface as in Figure 11.

Double left click on *res_bar.gzip* to unpack the sample files you will need for this example (Figure 11).

You should see a pop-up (Figure 13), *select unpack*.

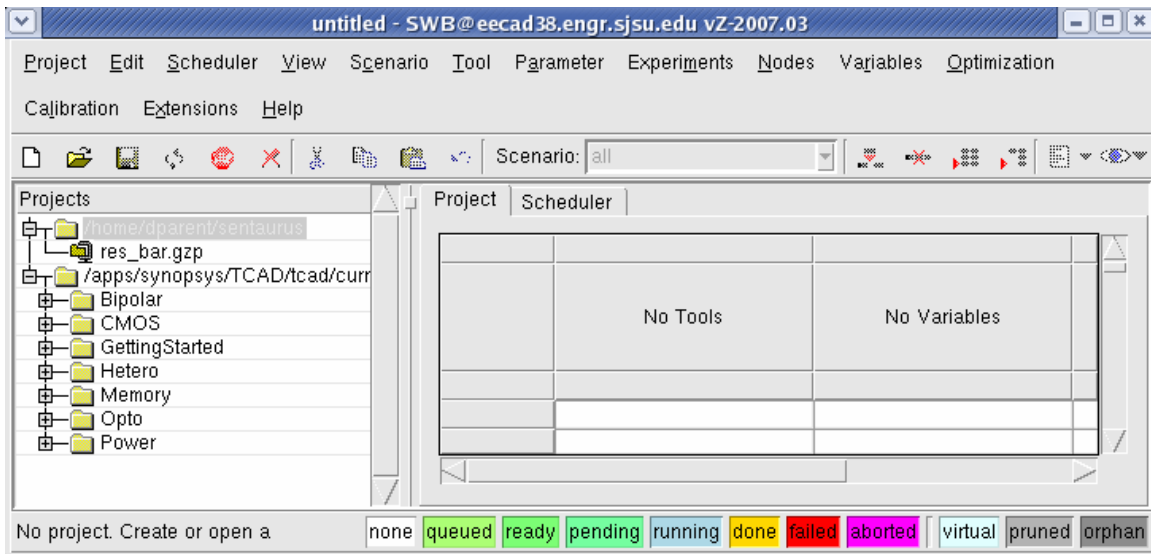


Figure 11: Sentaurus Workbench.

Another pop-up will appear, click twice to save the file (Figure 13). Note: /dparent is my directory, your directory will automatically be entered in.

If done properly you should see the project loaded into the SWB interface (Figure 14).

Table 1 shows what each parameter means (W, H, MGSX, MGSY, NA).

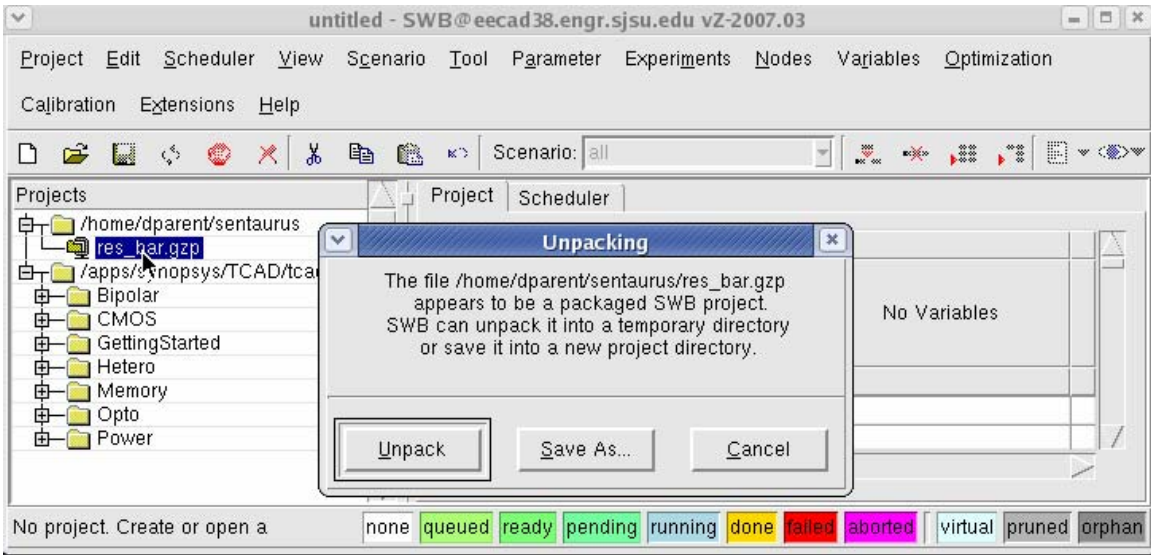


Figure 12: Click on Unpack.

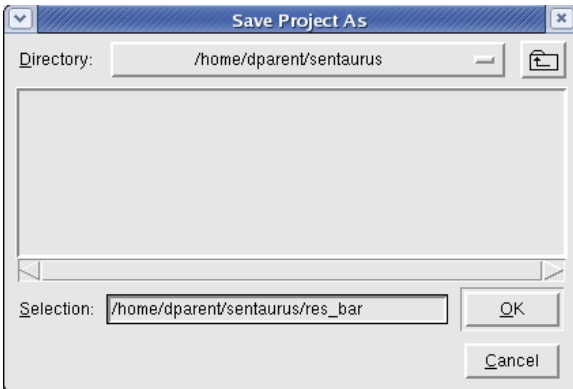


Figure 13: Click OK twice.

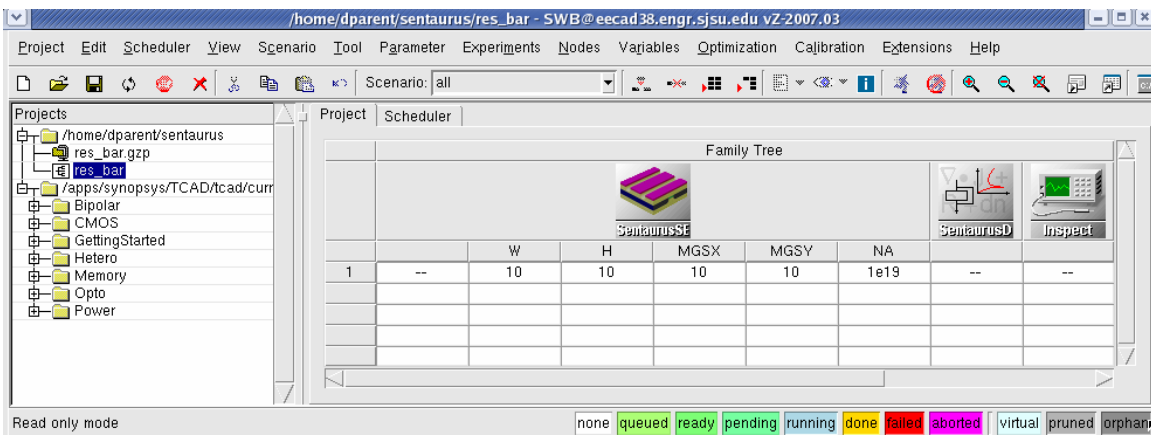


Figure 14: The resistor bar project is loaded.

Table 1: Parameter Names and Meanings.

Parameter Name	Meaning
W	Width of the Silicon Bar. Note: Current flows from top to bottom so the larger the width, the more current can flow.
H	Height of the silicon Bar. Note: Current flows from top to bottom so the larger the Height, the less current can flow.
MGSX	Maximum Grid Spacing in the X direction. How many grids along the width.
MGSY	Maximum Grid Spacing in the Y direction. How many grids along the Height.
NA	Substrate doping of the p-Substrate.

To see/edit the Sentaurus Structure Editor commands on the SWB interface, left click on the Sentaurus Structure Editor Icon and go to Edit Input... Commands (Figure 15). You should see the code in Figure 16.

To see/edit the Sentaurus Device commands on the SWB interface, left click on the Sentaurus Device Icon and go to Edit Input... Commands (Figure 17). You should see the code in Figure 18.

To see/edit the Inspect commands on the SWB interface, left click on the Inspect Icon and go to Edit Input... Commands (Figure 19). You should see the code in Figure 20.

Do not edit anything at this time!

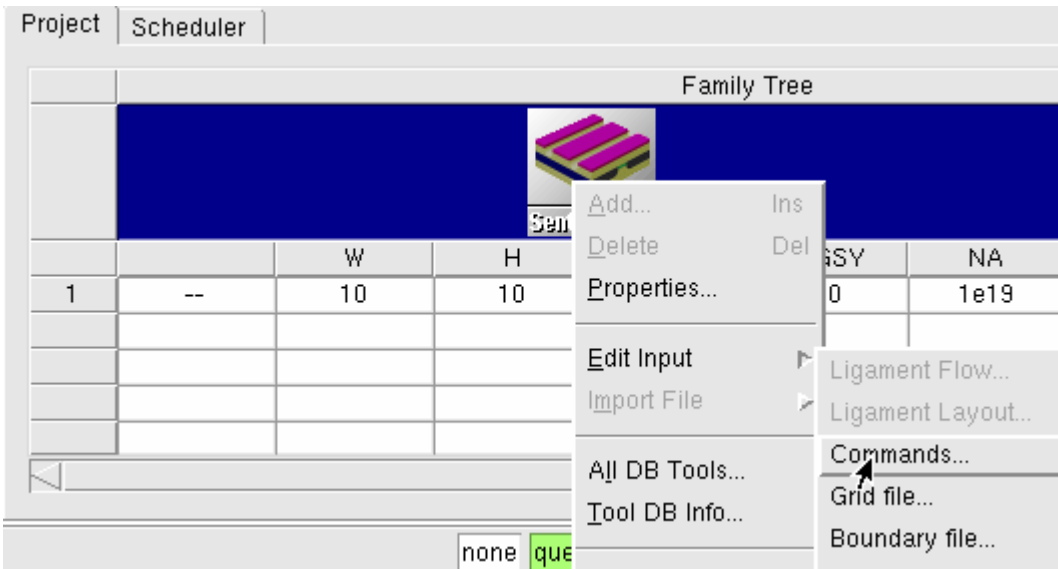


Figure 15: Showing Sentaurus Structure Editor commands.

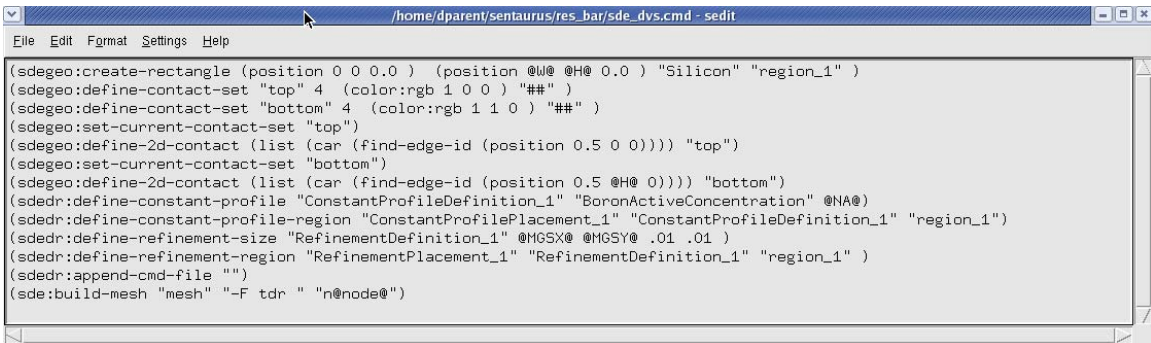


Figure 16: Commands for Sentaurus Structure Editor.

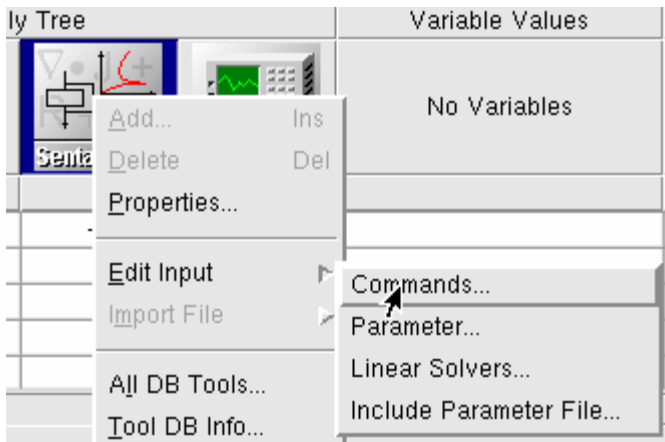


Figure 17: Showing Sentaurs Device commands.

```

/home/dparent/sentaurus/res_bar/sdevice_des.cmd - sedit
File Edit Format Settings Help
|!(
  set SIGN 1.0
  set EQNS "Poisson Electron"
)!
File {
  * input files:
  Grid= "@tdr@"
  Parameter="@parameter@"
  * output files:
  Plot= "@tdrdat@"
  Current="@plot@"
  Output= "@log@"
}
Electrode {
  { Name="top" Voltage=-2.0 }
  { Name="bottom" Voltage=0.0 }
}
Physics{
  EffectiveIntrinsicDensity( OldSlotboom )
}
Physics(Material="Silicon"){
  MLDA
  Mobility(
    PhuMob
  )
}

```

Figure 18: Commands for Sentaurs Device.

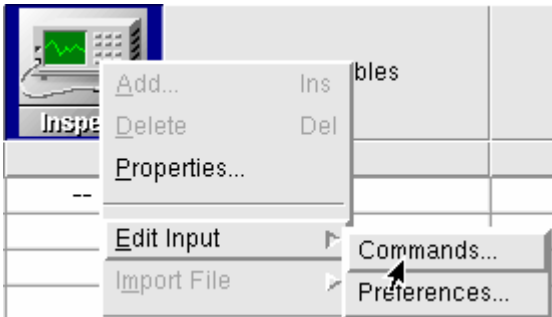


Figure 19: Showing commands for Inspect.

```

/home/dparent/sentaurus/res_bar/inspect_ins.cmd - sedit
File Edit Format Settings Help
|
#set Rave      x

set N         @node@
set i         @node:index@

set ID        "nMOS"
set Type      "nMOS"

#- Automatic alternating color assignment tied to node index
#-----#
set COLORS    [list green blue red orange magenta violet brown]
set NCOLORS   [llength $COLORS]
set color     [lindex $COLORS [expr $i%$NCOLORS]]

#- INSPECT IdVg plotting
#-----#
# Plotting Id vs Vg curves
gr_setTitleAttr "sssss"

proj_load    IdVg_@plot@ PLT($N)

cv_createDS  IdVg($N) \
  "PLT($N) top OuterVoltage" "PLT($N) top TotalCurrent" y

cv_setCurveAttr IdVg($N) "IdVg $ID" \
  $color solid 2 none 3 defcolor 1 defcolor

gr_setAxisAttr X {Gate Voltage (V)} 16 {} {} black 1 14 0 5 0
gr_setAxisAttr Y {Drain Current (A/um)} 16 {} {} black 1 14 0 5 1

#- Extraction
  
```

Figure 20: Inspect Commands.

To Run the project, first unlock it (Figure 21).

The in the SWB go to Project...Project Operations... Run.. (Figure 22).

You should see a pop-up (Figure 23), select ok.

After some time you should be able to see the results (Figure 24).

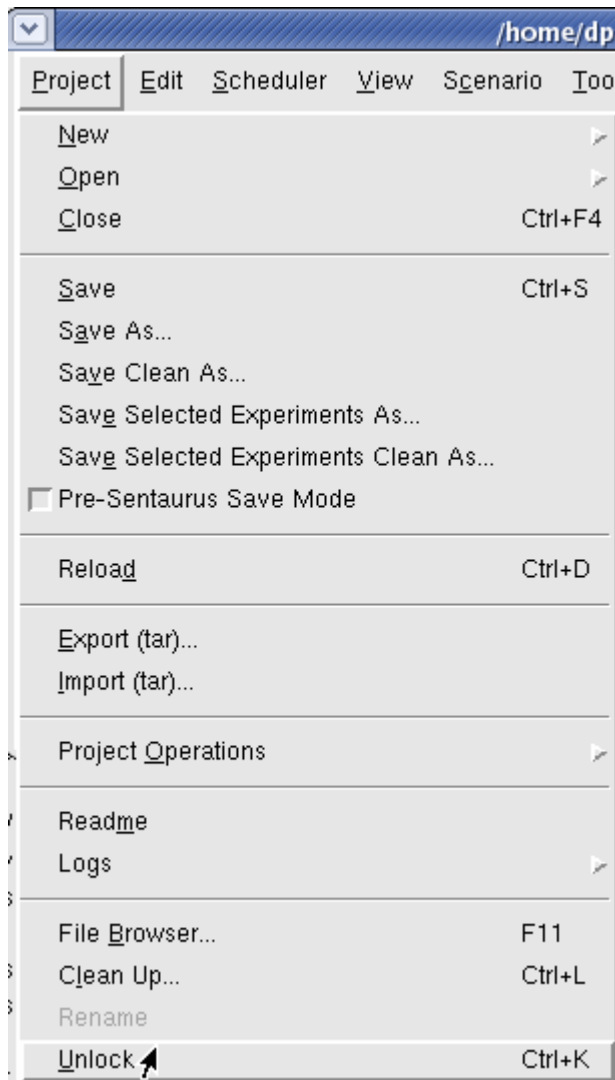


Figure 21: Unlocking the project.

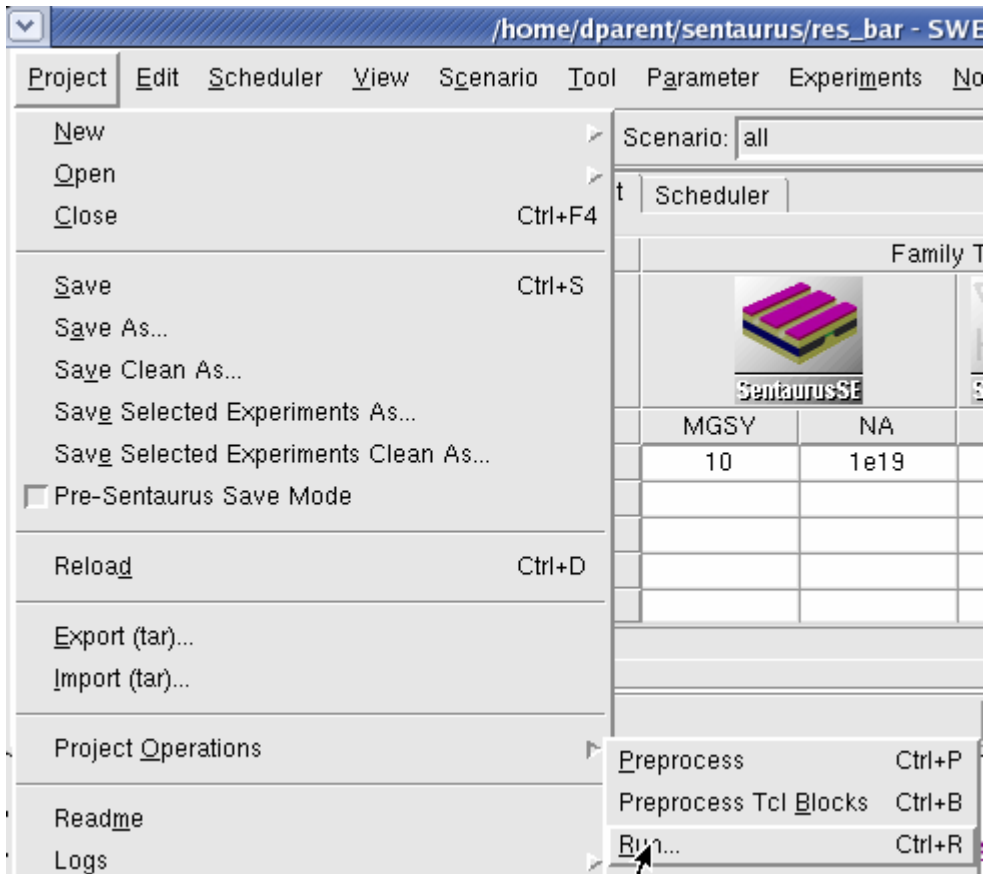


Figure 22: Running the project.

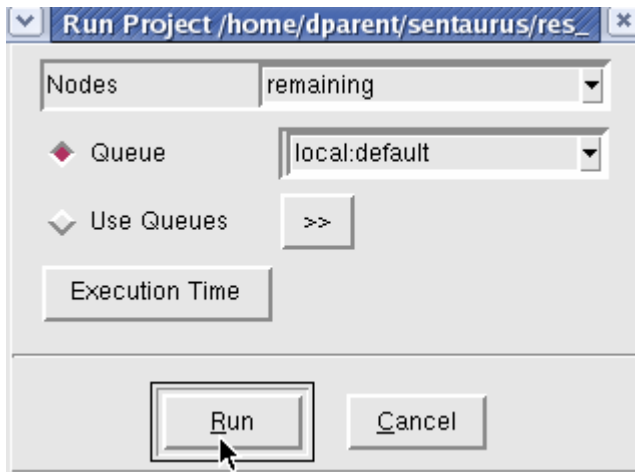


Figure 23: Setting the Queue to use for the project.

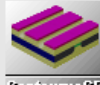


Family Tree									Variable Value
									
		W	H	MGSX	MGSY	NA			Rave
1	--	10	10	10	10	1e19	--	--	8.811e+01

Figure 24: Results of one run of the project.

To be able to see the 2-D cross sections down load the following file into your Sentauros directory:

http://www.engr.sjsu.edu/dparent/ee221/gpref_dparent.Z-2007.03

Go to Edit ...User preferences to verify all tech plot commands are of the type techplot_sv – mesa (Figure 25). An example is in Figure 26.

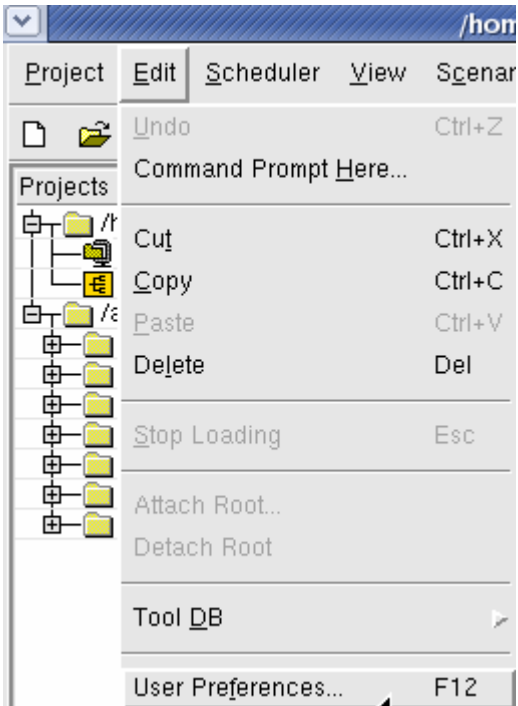


Figure 25: User Preferences.

	Entry Type	Entry Value
Binaries		
editor		
tool		
viewer		
acdat	File	tecplot_sv -mesa
boundary	File	sde
boundary2	File	tecplot_sv -mesa
dat	File	tecplot_sv -mesa
dmp/dios	File	xterm -e /apps/synopsys/TCAD/bin/dios
grid	File	tecplot_sv -mesa
ivinspect	File	inspect
ivitecplot	File	tecplot_sv -mesa
log	File	sedit
lyt	File	prolyt
package	File	tecplot_sv -ise:no_ise_reader
pitinspect	File	inspect
pittecplot	File	tecplot_sv -mesa
pkinspect	File	inspect
pktecplot	File	tecplot_sv -mesa
sav	File	inspect
tdftecplot	File	tecplot_sv -mesa
tdrinspect	File	inspect
tdrtdx	File	tdx
tdrtecplot	File	tecplot_sv -mesa
text	File	sedit
titecplot	File	tecplot_sv -mesa

Figure 26: Set all Tech_plot to tecplot_sv -mesa

To view the structure created by Sentaurus Structure Editor, left click on the 1e19 node and select tecplot SV (Figure 27). The results appear in Figure 28.

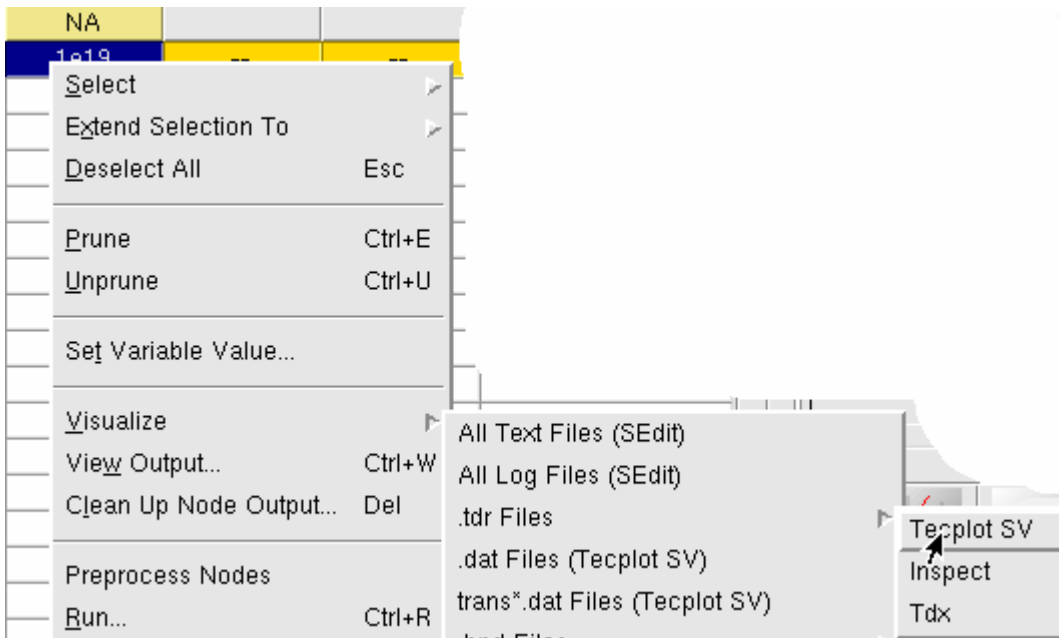


Figure 27: Viewing with tecplot_sv -mesa.

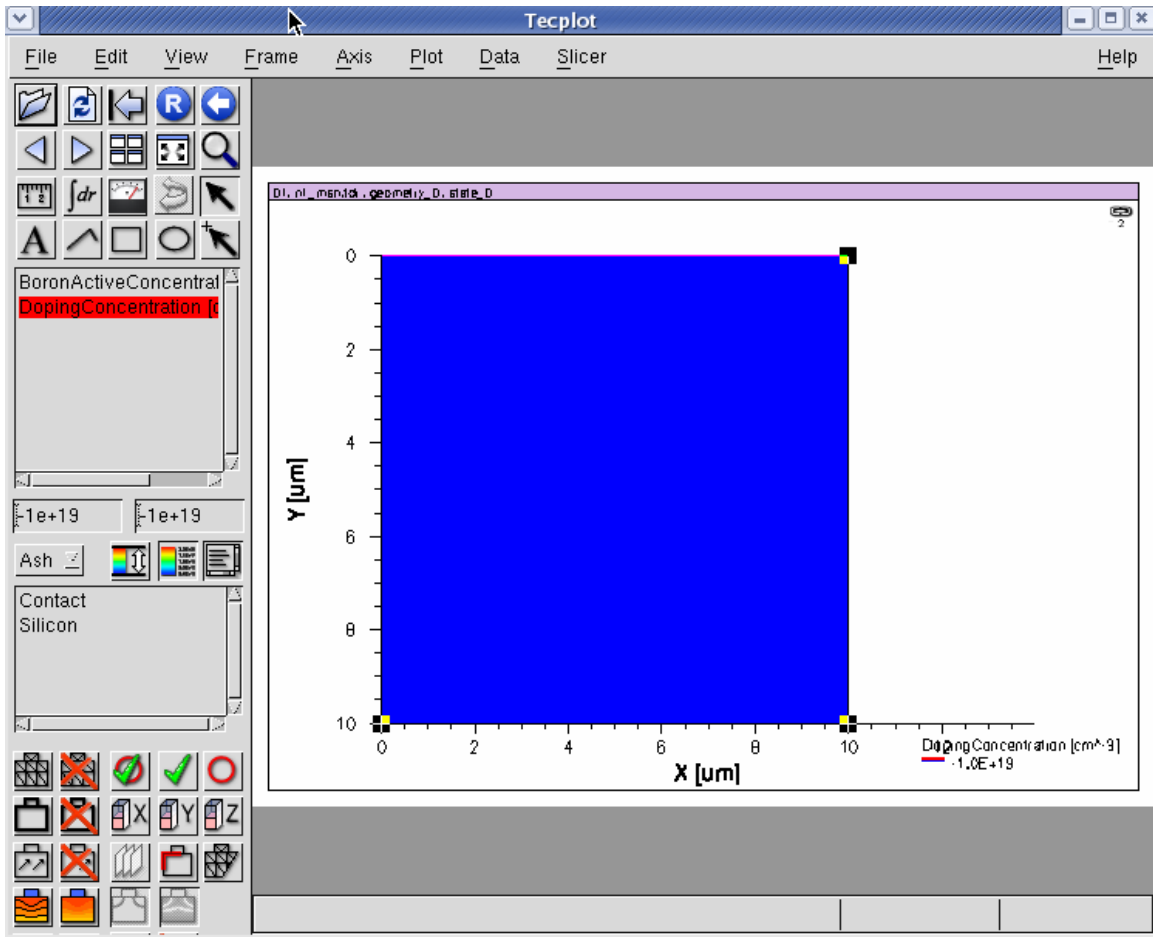


Figure 28: SDE results.

To view the electrical results right click on the SDevice node and go to Visualize, plt. Files... Inspect ans in XX.. Inspect should appear as in ..

To plot the results click on the node IDVG_n10_des , then top, then OuterVoltage as in Figure 30, and then click X-axis. Repeat for Total current but click n Y axis (Figure 31). The results should appear as in Figure 32.

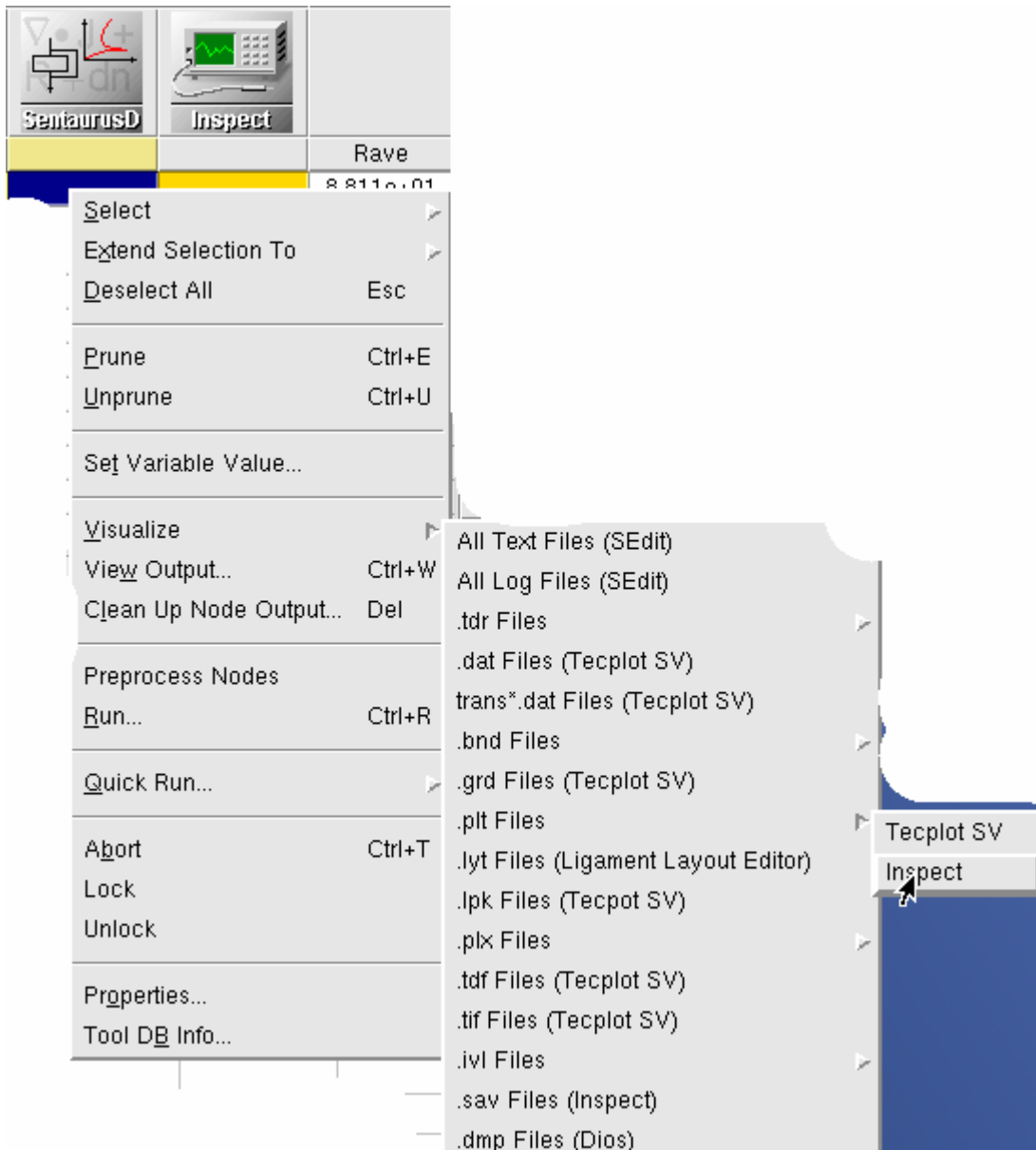


Figure 29: Plotting Results from SDevice with Inspect.

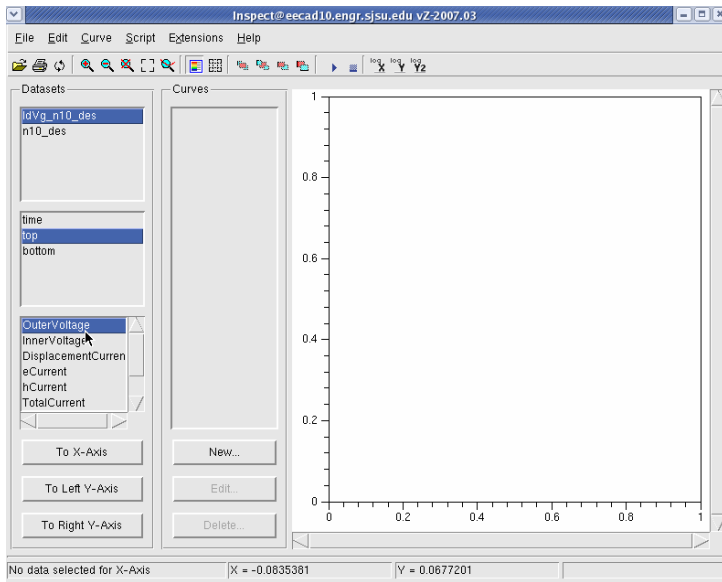


Figure 30: Setting X-Axis.

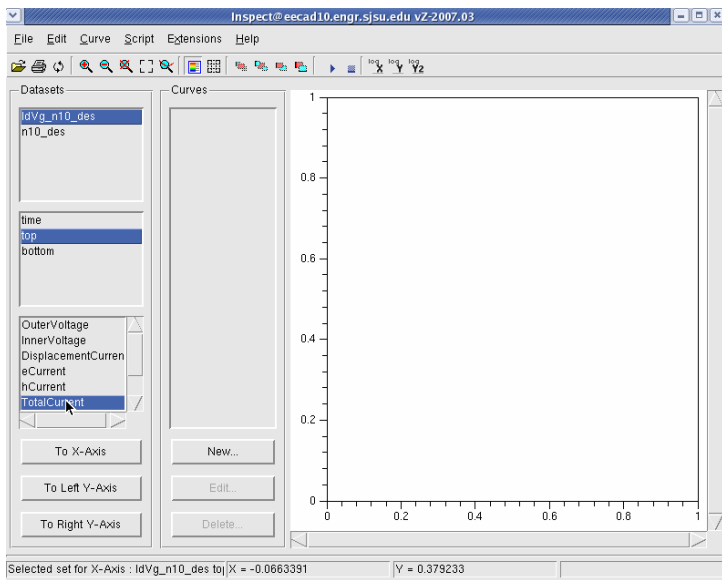


Figure 31: Setting Y-Axis

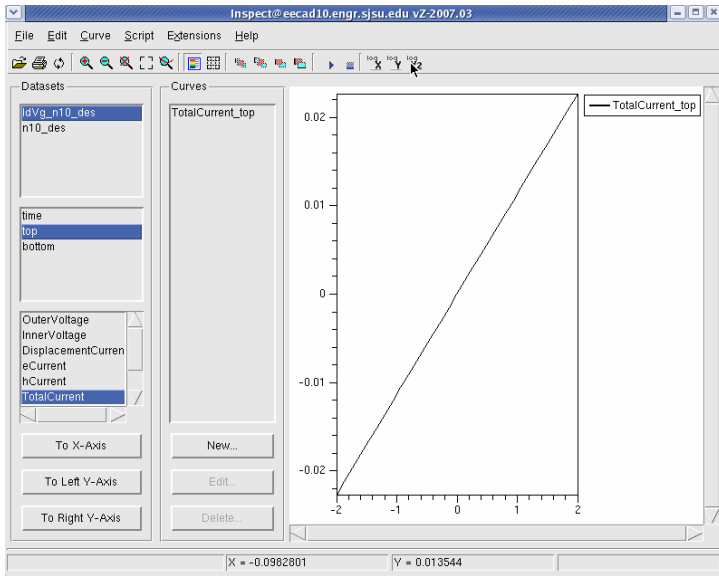


Figure 32: Electrical Results for a Bar of Silicon.

To see the affect on simulation time a accuracy of results change the variables MGSX and MGSY variables to .1 as in Figure 33 to Figure 36. Your SWB interface should look like Figure 37.

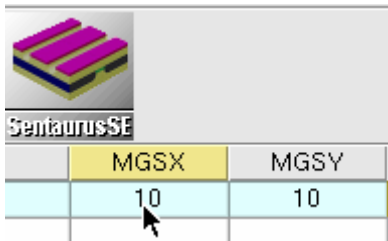


Figure 33: Changing MGSX to .1um.

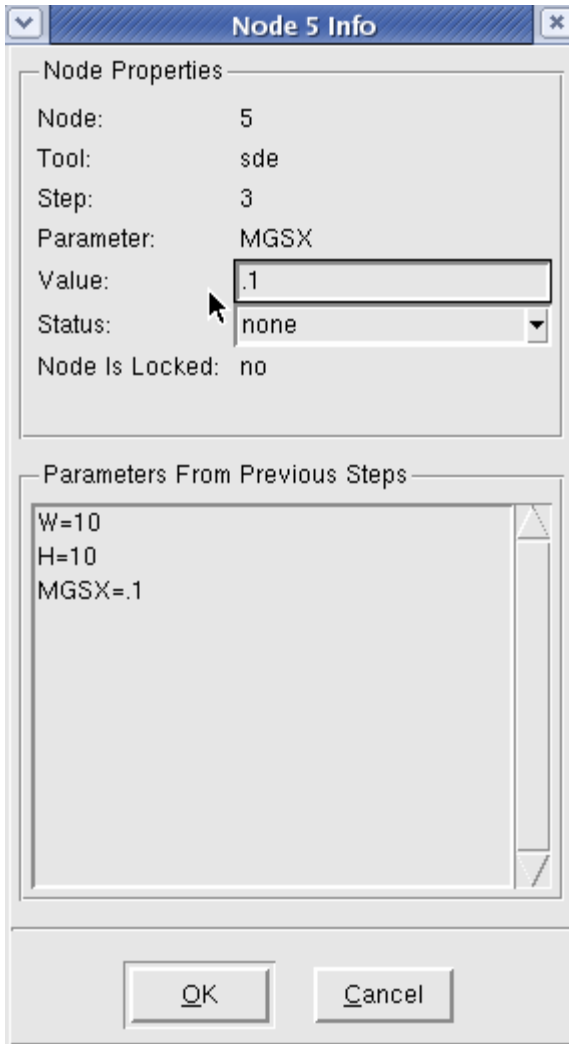


Figure 34: Change value of MGSX.

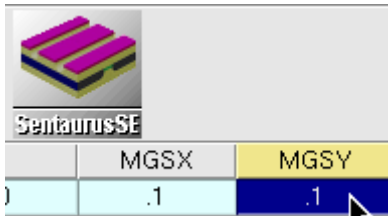


Figure 35: MGSY to .1um.

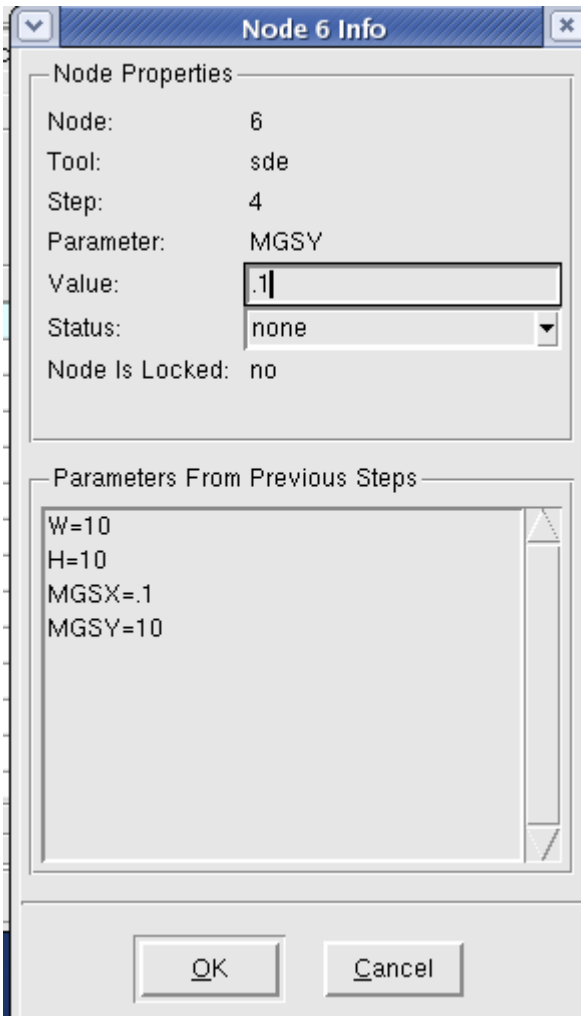


Figure 36: Change value of MGSY.

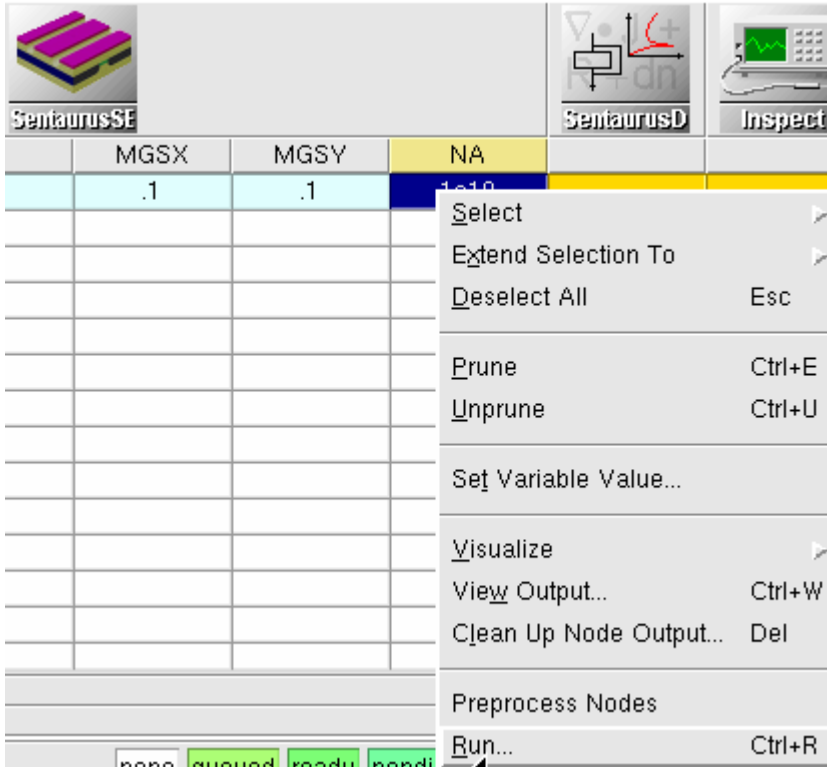


Figure 37: Rerun the project.

To rerun the project node click on the node and select run (Figure 37). Click yes to save the project (Figure 38). When complete use tecplot to view the results. When tecplot appears click on the grid icon and you should get the results shown in Figure 39.

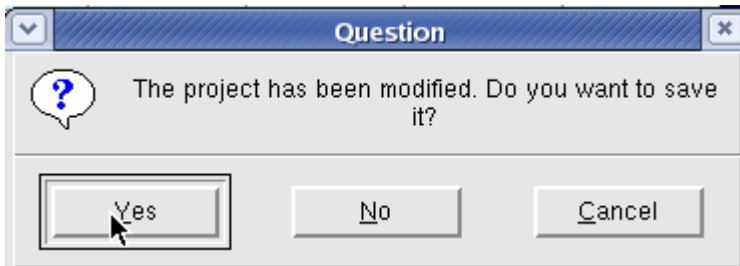


Figure 38: Saving Project.

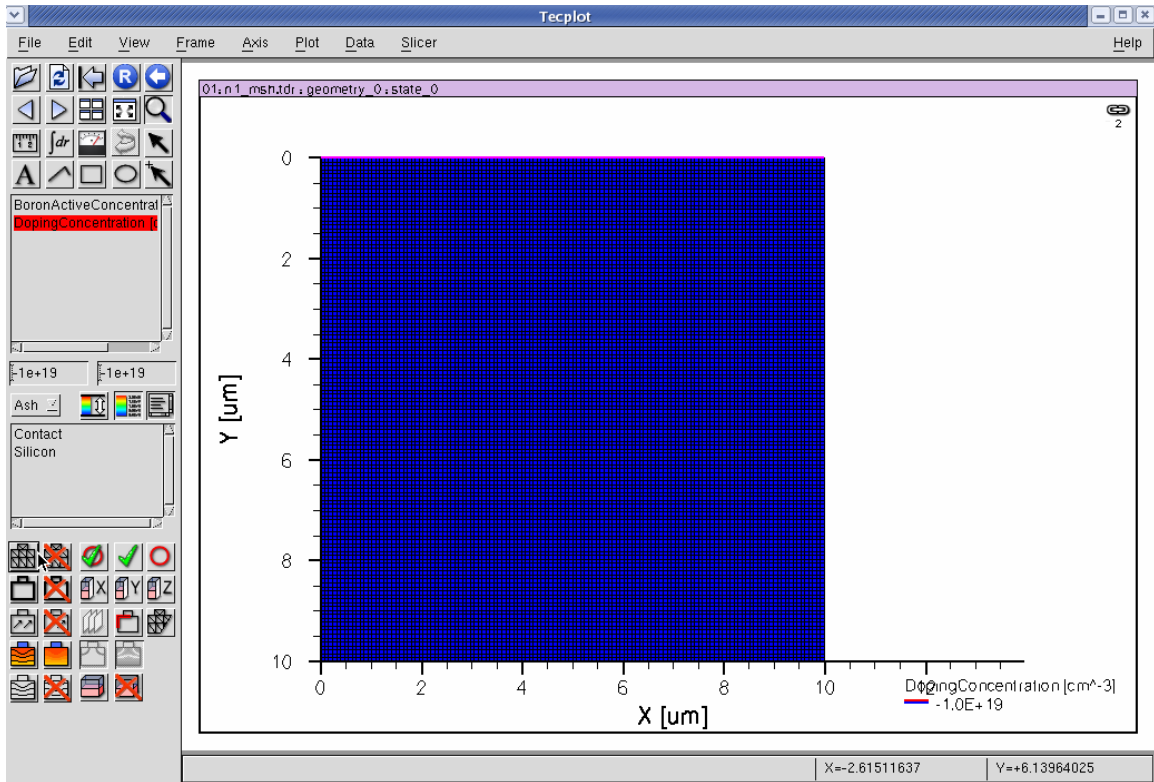


Figure 39: Results of finer grid.

To view the run time statistics, click on the proper node in the SDevice column, and goto view output (Figure 40). You should see the start of your project (Figure 41), and the end (Figure 42).

Note, even though the project took significantly longer to run the results are the same (Figure 43)! Why????

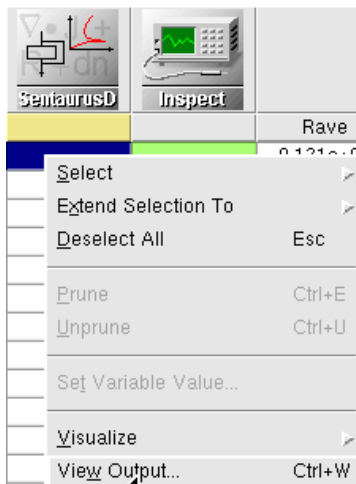


Figure 40: Viewing the SDevice run time.

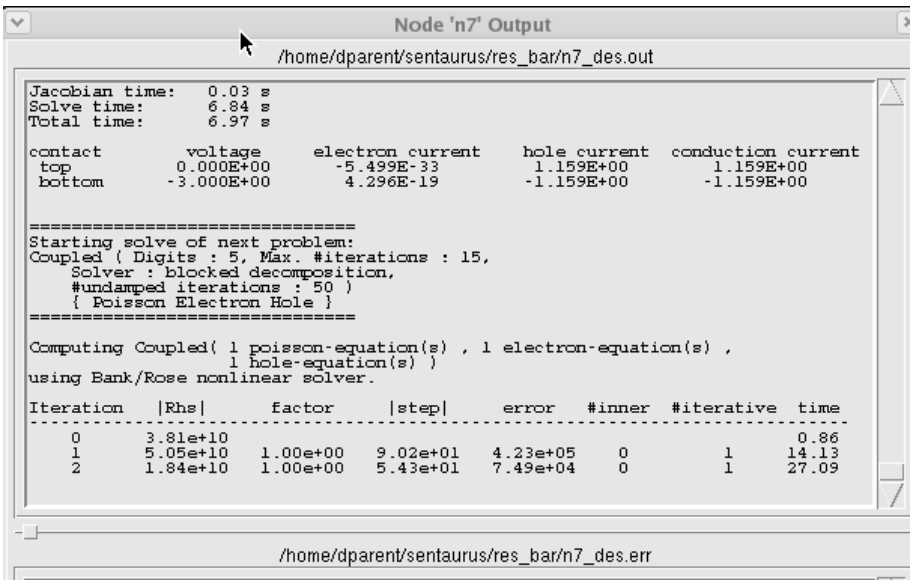


Figure 41: Sdevice starts.

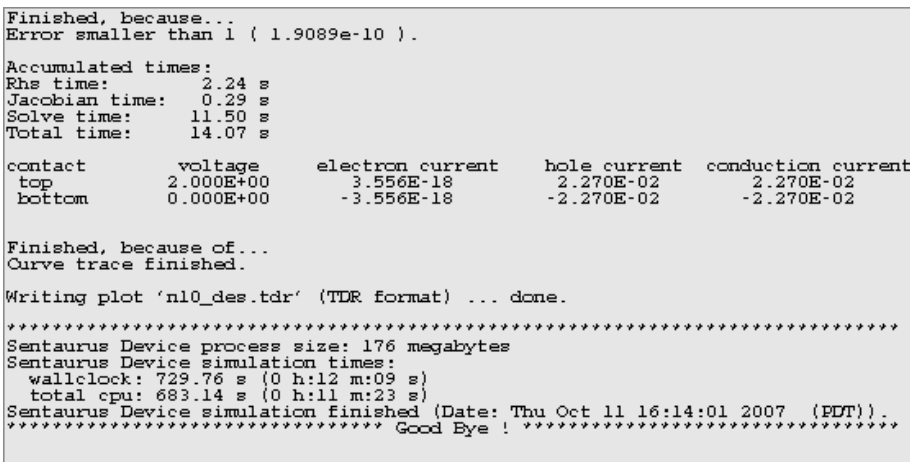


Figure 42: Run statistics for Sdevice.

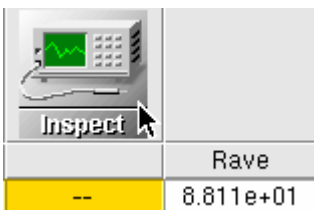


Figure 43: No change in results!

To make a series of experiments you need to add values to the variable columns. For example we wish to see how resistance of the bar changes with doping levels from 10^{14}cm^{-3} to from 10^{19}cm^{-3} .

First change the $1e19$ node to $1e14$ as in Figure 44. Add values by clicking on NA, and going to Add Values (Figure 45). Fill out the pop-up according to Figure 46. The SWB manager should look like Figure 47. Change the MGSX, and MGSY back to 10 and you should be ready to simulate (Figure 48).

Before you can run the project you need to “clean it up”. In the SWB manager go to Project Cleanup (Figure 49), and click OK on the pop-up (Figure 50), your SWB manager should look like Figure 51. Run the project and you should see the results as in Figure 52.

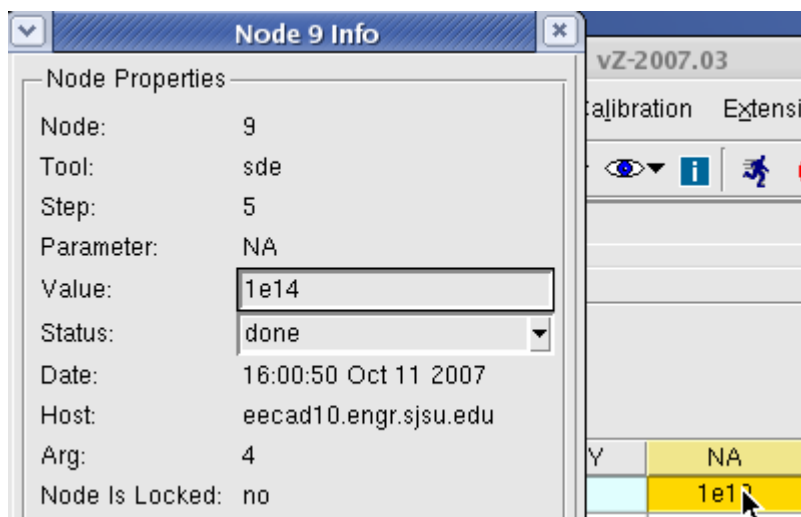


Figure 44: Editing a variable.

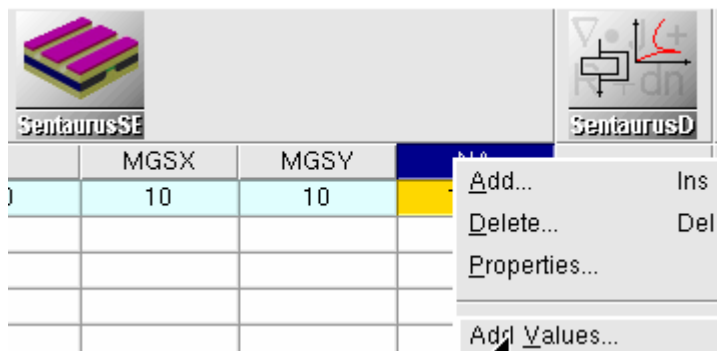


Figure 45: Adding experimental values.

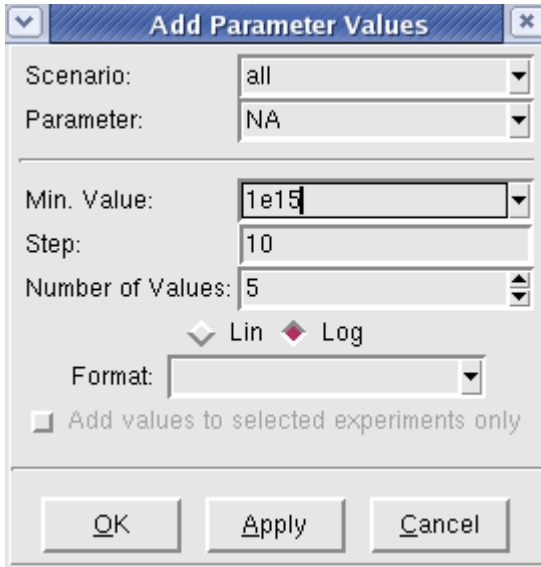


Figure 46: Add 5 values at powers of 10 doping levels.

SentaurosSE					SentaurosD		Inspect	Rave
	W	H	MGSX	MGSY	NA			
--	10	10	.1	.1	1e14	--	--	8.811e+01
					1e15	--	--	
					1e+16	--	--	
					1e+17	--	--	
					1e+18	--	--	
					1e+19	--	--	

Figure 47: Experiments almost all set up.

SentaurosSE					SentaurosD		Inspect	Rave
	W	H	MGSX	MGSY	NA			
--	10	10	10	10	1e14	--	--	8.811e+01
					1e15	--	--	
					1e+16	--	--	
					1e+17	--	--	
					1e+18	--	--	
					1e+19	--	--	

Figure 48: Change MGSX and MGSY back to 10.

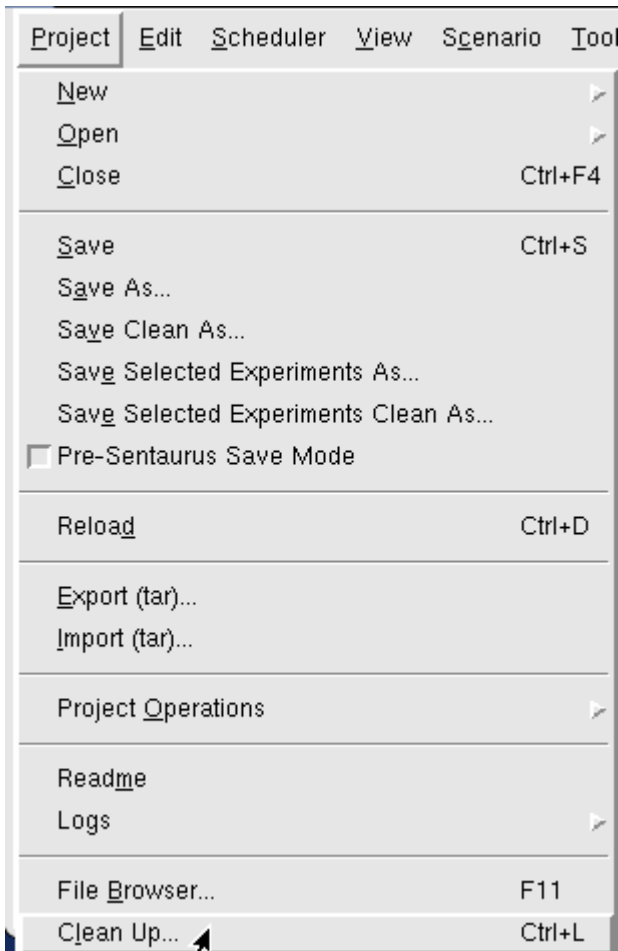


Figure 49: Cleanup project.

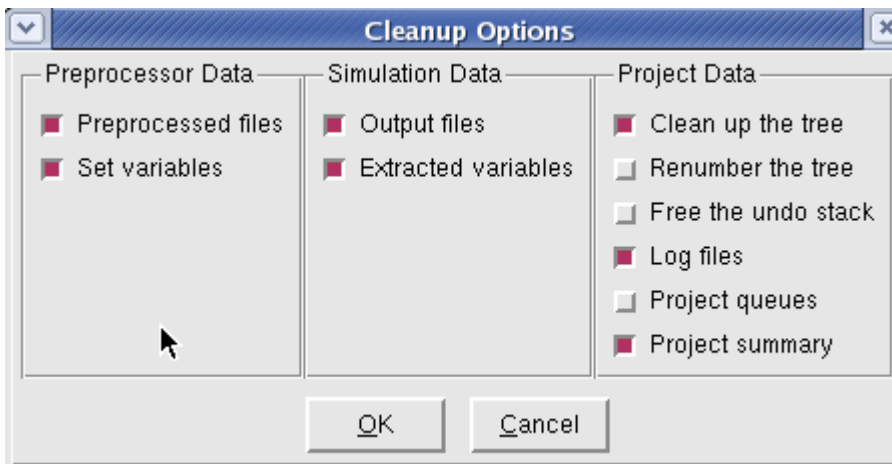


Figure 50: Clean up results.

SentaurosSE					SentaurosD	Inspect
	W	H	MGSX	MGSY	NA	
--	10	10	10	10	1e14	--
					1e15	--
					1e+16	--
					1e+17	--
					1e+18	--
					1e+19	--

Figure 51: Project ready to run.

	W	H	MGSX	MGSY	NA			Rave
--	10	10	10	10	1e14	--	--	1.331e+06
					1e15	--	--	1.351e+05
					1e+16	--	--	1.454e+04
					1e+17	--	--	1.966e+03
					1e+18	--	--	4.083e+02
					1e+19	--	--	8.811e+01

Figure 52: Results.

Once can cut and past the doping levels and R values into open office.Calc(Figure 53). One can plot the results as in (Figure 54). **What is the kink in R at the doping level of 10^{17} cm^{-3} ?**

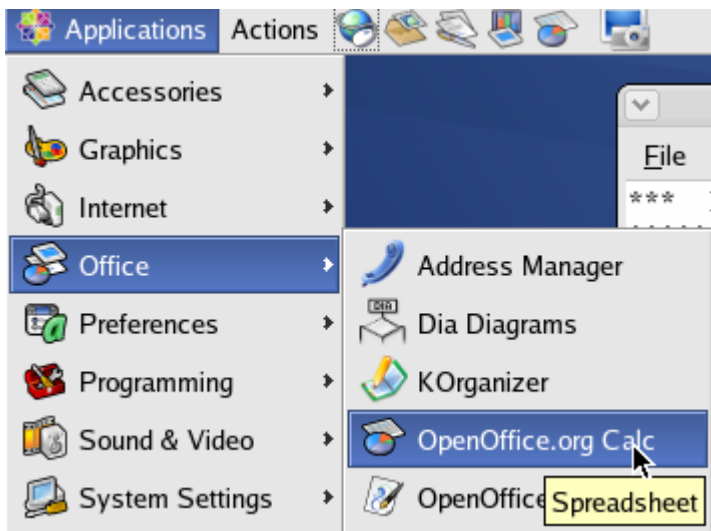


Figure 53: Opening Open Office Calc

Resistance vs. Substrate Doping for a P-Type Bar of Silicon 10 microns wide by 10 microns deep

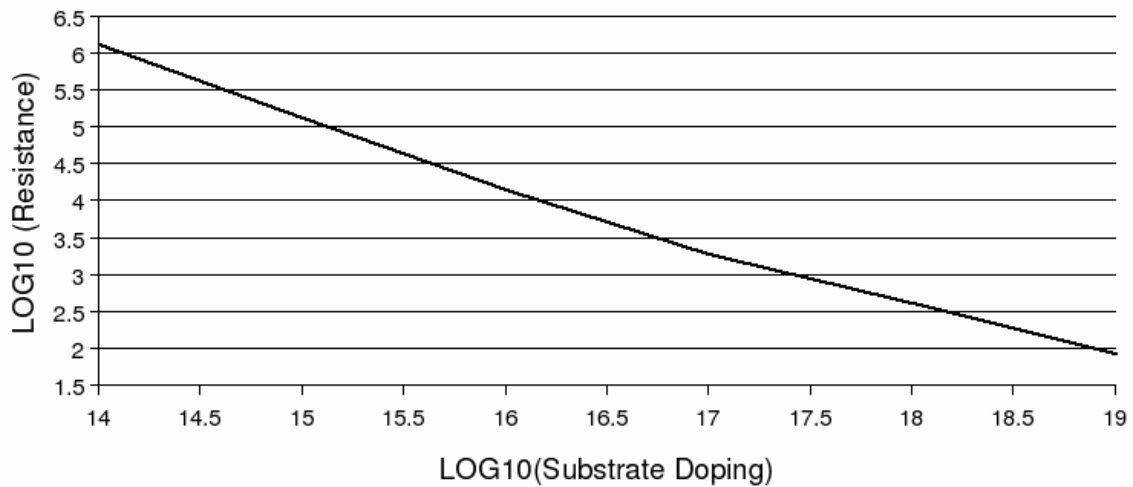


Figure 54: Results of varying the doping levels of a Silicon Bar.

In order to run another one parameter experiment we need to delete the values for NA. To do this, click on NA and delete it (Figure 55). You can keep the suggested value in pop up Figure 56.

Add NA back this time with a value of 10^{16}cm^{-3} (Figure 57). Your SWB manager should look like Figure 58.

To vary H, the height of the bar of silicon, click on H and add the values according to pop up Figure 59. Your SWB manager should look like Figure 60. Cleanup the project and re-run it. You should get results like Figure 61.

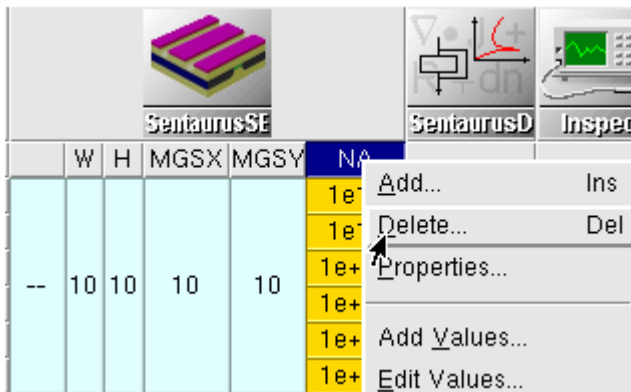


Figure 55: Deleting a variable.

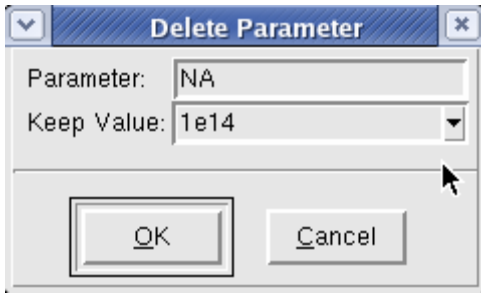


Figure 56: Selecting which value to keep.

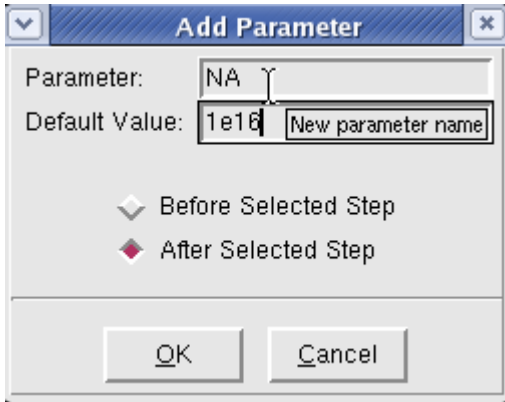


Figure 57: Adding the parameter back.

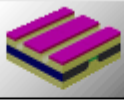
 SentrySE					
	W	H	MGSX	MGSY	NA
--	10	10	10	10	1e16

Figure 58: NA added back.

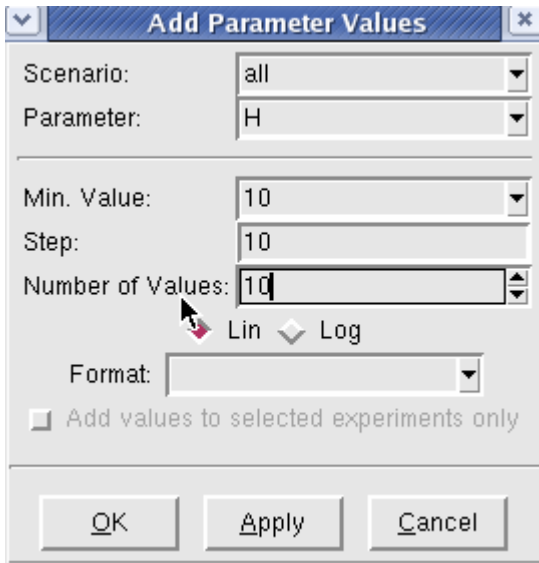


Figure 59: Adding values to the H.



								
	W	H	MGSX	MGSY	NA			Rave
--	10	10	10	10	1e16	--	--	1.812e+06
		20	10	10	1e16	--	--	
		30	10	10	1e16	--	--	
		40	10	10	1e16	--	--	
		50	10	10	1e16	--	--	
		60	10	10	1e16	--	--	
		70	10	10	1e16	--	--	
		80	10	10	1e16	--	--	
		90	10	10	1e16	--	--	
		100	10	10	1e16	--	--	

Figure 60: Varying H in the SWB manager.



								
	W	H	MGSX	MGSY	NA			Rave
--	10	10	10	10	1e16	--	--	1.924e+04
		20	10	10	1e16	--	--	3.306e+04
		30	10	10	1e16	--	--	4.725e+04
		40	10	10	1e16	--	--	6.156e+04
		50	10	10	1e16	--	--	7.594e+04
		60	10	10	1e16	--	--	9.035e+04
		70	10	10	1e16	--	--	1.048e+05
		80	10	10	1e16	--	--	1.192e+05
		90	10	10	1e16	--	--	1.337e+05
		100	10	10	1e16	--	--	1.482e+05

Figure 61: Results of Varying H.

Looking at Figure 62 it seems the R is linear with H (Note: the current flow is from top to bottom of this structure so in the case $L=H$ Since $R=\rho \times L / \text{Area}$). This makes sense according to the equation but what about the mobility reduction to velocity saturation? If we edit the SDevice command file we see Figure 63, with no mobility flag for this effect. Add the effect in by changing the SDevice command file to HighFieldSaturation Figure 64.

After editing the command file select the nodes and preprocess them to update the changes in the command file (Figure 66). Select the nodes again and run. This will only run Sdevice and Nspect. The structures are the same so do not re-run them. This saves quite a bit of time.

You should get the results as shown in Figure 65. Note that if you plot it out against the last run there is not much difference, why? Hint: Try running the simulation with H from 1 to 10 in steps of ten. Make sure to change MGSY to 1 (Figure 67)! Note you will not see much difference in R as in the way it is extracted. Look at the plots of current to see what is going on.

R vs. Hieght of a Silicon Bar

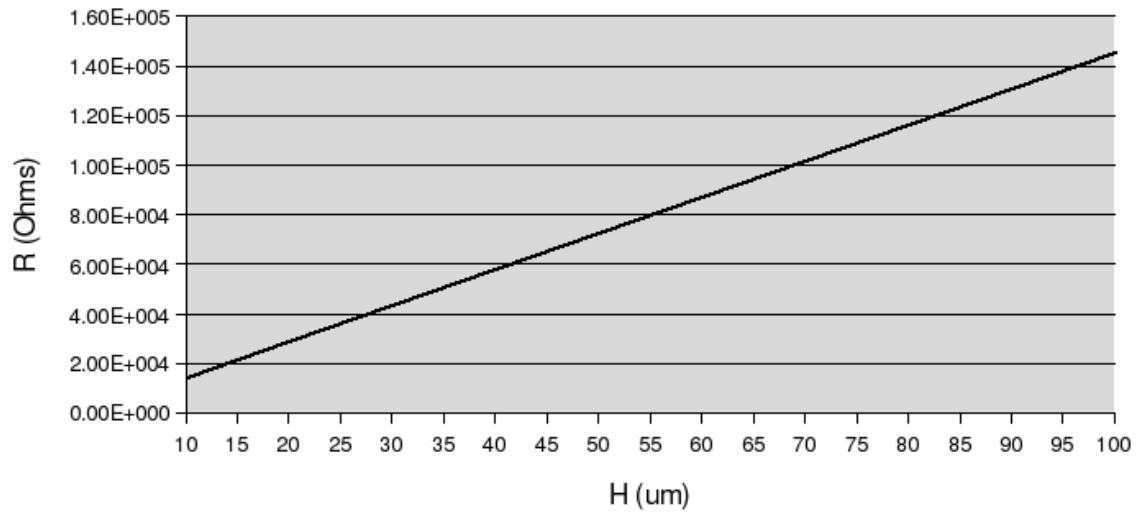


Figure 62: R. Vs H.

```

}

Physics{
    EffectiveIntrinsicDensity( OldSlotboom )
}

Physics(Material="Silicon"){
    MLDA
    Mobility(
        PhuMob

```

Figure 63: Physics statement.

```

Physics(Material="Silicon"){
    MLDA
    Mobility(
        PhuMob
        HighFieldSaturation
    )

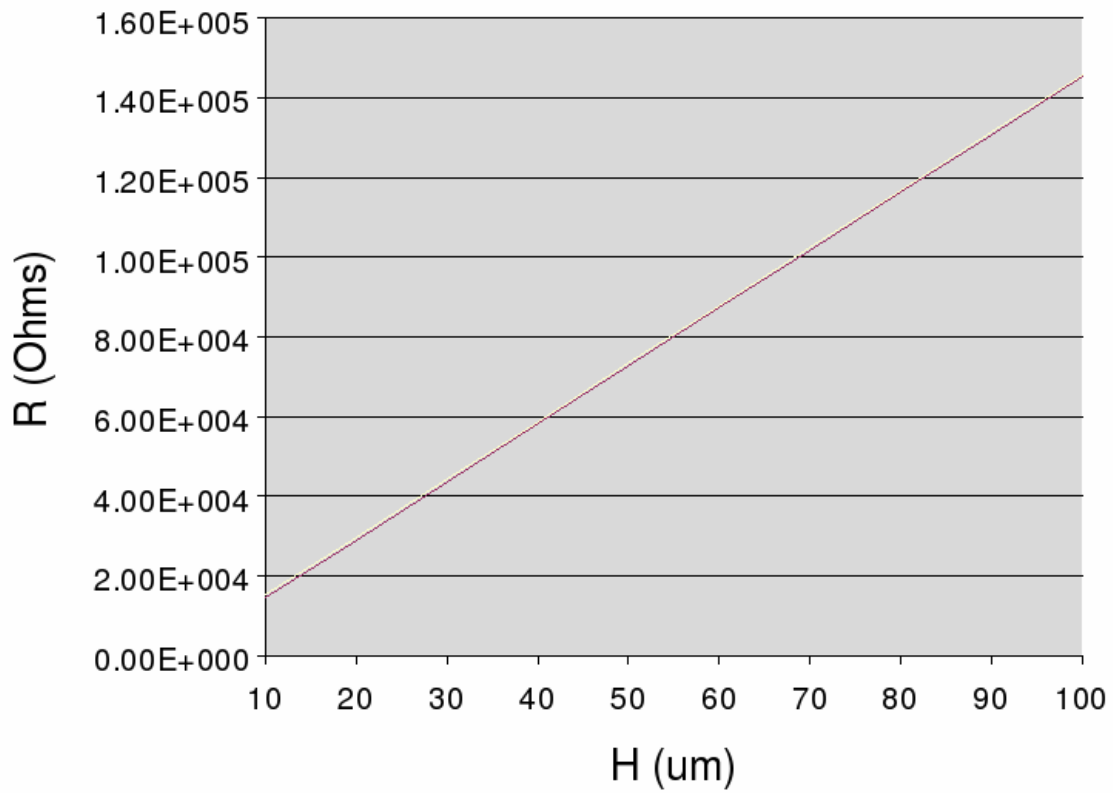
```

Figure 64: HighFieldSaturation Flag.

10	10	1e16	--	--	1.534e+04
10	10	1e16	--	--	2.978e+04
10	10	1e16	--	--	4.426e+04
10	10	1e16	--	--	5.877e+04
10	10	1e16	--	--	7.328e+04
10	10	1e16	--	--	8.780e+04
10	10	1e16	--	--	1.023e+05
10	10	1e16	--	--	1.168e+05
10	10	1e16	--	--	1.314e+05
10	10	1e16	--	--	1.459e+05

Figure 65: Results with High Field Mobility.

R vs. Height of a Silicon Bar



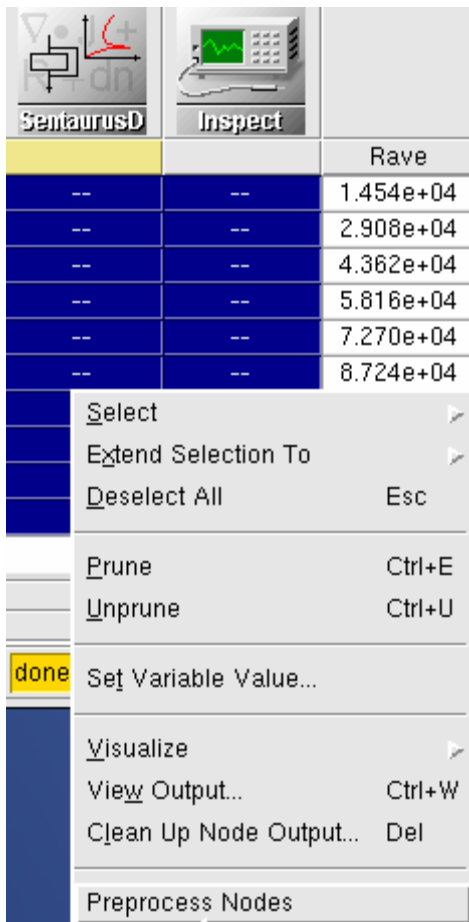


Figure 66: Preprocess Nodes.

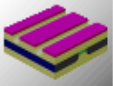


  							
	W	H	MGSX	MGSY	NA		
--	10	1	10	1	1e16	--	--
		2	10	1	1e16	--	--
		3	10	1	1e16	--	--
		4	10	1	1e16	--	--
		5	10	1	1e16	--	--
		6	10	1	1e16	--	--
		7	10	1	1e16	--	--
		8	10	1	1e16	--	--
		9	10	1	1e16	--	--
		10	10	1	1e16	--	--

Figure 67: New Experiment H=1-10um, and MGSY=1um.